

Supporting Information

One-step growth of needle and dendritic gold nanostructures on silicon for surface enhanced Raman scattering

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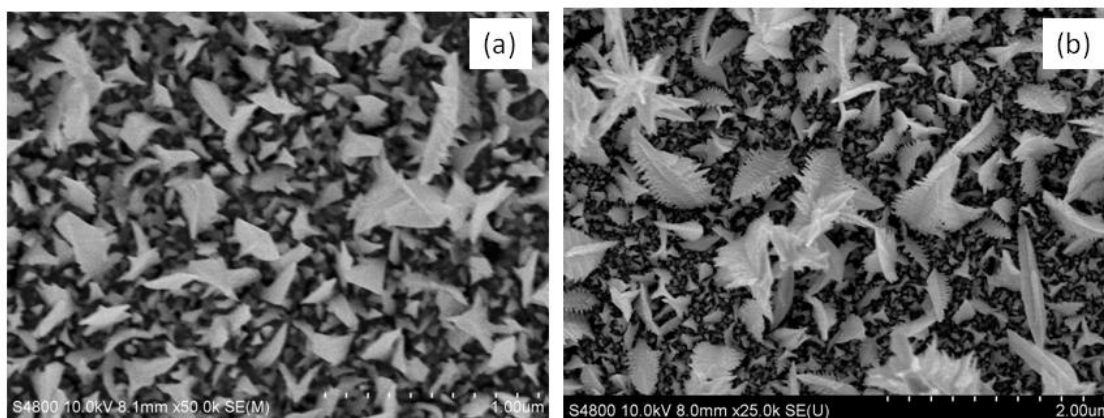


Figure S1 (a): Morphology of gold deposited on p-type silicon in presence of green laser. Irregular morphology with dendritic features is observed. (b) In presence of red laser wherein flat dendrites are observed